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From: HGAISCH --VCH0021A Date and time 06/05/89 07:57:57
To: SPARRISH--VCH0021A Steve Parrish

TO : Mr. S. Parrish
FROM : Helmut Gaisch (S&T)
SUBJECT: Internal Seminar

Dear Steven,

This is to invite you to take part in the seminar entitled "Risk Assessment Associated with Low Dose Exposures", which we are planning to hold on Thursday and Friday, 28th/29th September, 1989, in Neuchatel.

The purpose of the seminar is to assess the present state of knowledge by bringing together a diversity of disciplines, which are involved in this complex question.

The format of the seminar is that each participant is encouraged to state his view on the subject. These views will then be discussed, enabling us to come up with a synthesis representing the present state of knowledge, its limits and the areas where further research might be needed.

You, and the other participants, should have been invited earlier. Unfortunately we had some difficulties with some preparatory steps. Please accept my appologies.

Kind regards,

Helmut Gaisch

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